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Substitute for form 1449A/B/PTO		Complete if Known				
		Application Number	10/646,673-Conf. #1020			
INFORMATION DISCLOSURE				Filing Date	August 21, 2003	
**	STATEMENT BY APPLICANT			First Named Inventor	Kevin L. Beaman	
"				Art Unit	1762	
1	(Use as many sheets as necessary)			Examiner Name	David Turocy	
Sheet	1	of	2	Attorney Docket Number	108298715US	

			U.S. PATENT	DOCUMENTS	
Examiner Cite No.'		 Document Number	Publication Date MM-DD-YYYY 05-08-1990	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> ( if known)		Applicant of Cited Document	
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Examiner Initials*	Cite No.¹	Foreign Patent Document  Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>3</sup> (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Pocument	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
DPT		JP-63-111177-A	05-16-1988	Hitachi Ltd.		L		
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered, include copy of this form with next communication to applicant. \* CITE NO.: Those application(s) which are marked with an single asterisk (\*) next to the Cite No. are not supplied (under 37 CFR 1.98(a)(2)(iii)) because that application was filed after June 30, 2003 or is available in the IFW. Applicants unique citation designation number (optional). \* See Kinds Codes of USPTO Patent Documents at <a href="www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. \* Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). \* For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. \* Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. \* Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²		
DPT		Aera Corporation, "Fundamentals of Mass Flow Control," 1 page, retrieved from the Internet on March 6, 2003, <a href="http://www.aeramfc.com/funda.shtml">http://www.aeramfc.com/funda.shtml</a> >.			
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Examiner /David Turocy/	Date Considered	09/05/2006

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STA	STATEMENT BY APPLICANT (Use as many sheets as necessary)			First Named Inventor	Kevin L. Beaman
				Art Unit	1762
				Examiner Name	David Turocy
Sheet	2	of	2	Attorney Docket Number	108298715US

DPT	EMCO Flow Systems, "Mach One Mass Flow Controller Product Brochure" 6 pages, retrieved from the Internet on November 7, 2003, <a href="http://www.emcoflow.com/literature/brochures_product_sheets/mach_one/mach_one_brochure_2_01.pdf">http://www.emcoflow.com/literature/brochures_product_sheets/mach_one/mach_one_brochure_2_01.pdf</a> .	
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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&#</sup>x27;Applicant's unique citation designation number (optional). <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.